



2814

**TRANSMITTAL
FORM**

(to be used for all correspondence after initial filing)

Total Number of Pages in this Submission

3

Application Number

09/592,349

Filing Date

June 12, 2000

First Named Inventor

William C. Peatman et al.

Group Art Unit

2814

Examiner Name

D. Wille

Attorney Docket Number

SC11100ZP

ENCLOSURES

(check all that apply)

☐ Fee Transmittal Form☐ Fee Attached☐ Amendment/Reply☐ After Final☐ Affidavits/Declaration(s)☐ Extension of time Request☐ Express Abandonment Request☐ Information Disclosure Statement☐ Certified Copy of Priority Documents☐ Response to Missing Parts/
Incomplete Application☐ Response to Missing Parts
Under 37 CFR 1.52 or 1.53☐ Assignment Papers
(for an Application)☐ Drawing(s)☐ Licensing-Related papers☐ Petition☐ Petition to Convert to a
Provisional Application☐ Power of Attorney, Revocation,
Change of Correspondence
Address☐ Terminal Disclaimer☐ Request for Refund☐ CD, Number of CDs

Remarks

☐ After Allowance☐ Communication to Group☐ Appeal Communication to Board
of Appeals and Interferences☐ Appeal Communication to Group
{Appeal Notice, Brief, Reply Brief}☐ Proprietary Information☐ Status Letter with appropriate copies☒ Other Enclosure(s) (please identify below)☒ Response to Restriction Requirement☐ Associate Power of Attorney☐ RCE**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT**Firm or
Individual

Miriam Jackson

Registration No.

33,911

Signature

Date

September 3, 2001

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage thereon, as first-class mail, in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on the date listed below:

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Signature

Date

September 3, 2001



UNITED STATES PATENT AND TRADEMARK OFFICE

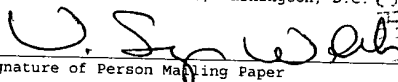
APPLICANT(S) William C. Peatman et al. GROUP ART UNIT: 2814
 APPL. NO.: 09/592,349 EXAMINER: D. Wille
 FILED: June 12, 2000
 TITLE: METHOD OF MANUFACTURING A SEMICONDUCTOR COMPONENT AND
 SEMICONDUCTOR COMPONENT THEREOF

#5
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RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents
 Washington, D.C. 20231

Sir:

This paper is in response to the restriction requirement in the Office
 Action mailed September 4, 2001.

REMARKS

A restriction of applicants' claims was required under 35 U.S.C. §121 for the
 following groups of claims:

- I. Claims 1-21, drawn to a method, and
- II. Claims 22-25, drawn to a device.

As required by the Office Action, applicants provisionally elect,
 subject to a traverse that follows hereafter, to prosecute the semiconductor
 method claims of Group I, claims 1-21.